

S/N: TBA

1/22/2002

DOCKET NO.: KAW-269-USAP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Zongtao GE

Serial No.: TO BE ASSIGNED

Art Unit: TO BE ASSIGNED

Filed: January 22, 2001

Examiner: TO BE ASSIGNED

For: Phase Shift Fringe Analysis Method and Apparatus Using the Same

APPLICATION DATA SHEET

(1) APPLICANT INFORMATION

Sole Inventor
Residence
Mailing Address

Zongtao GE
Saitama-shi, Saitama, JAPAN
FUJI PHOTO OPTICAL CO., LTD.
1-324, Uetakecho
Saitama-shi, Saitama 330-8624
JAPAN

Citizenship

CHINESE

(2) CORRESPONDENCE INFORMATION

Ronald R. Snider
Snider & Associates
P.O. Box 27613
Washington, DC 20038-7613

(3) APPLICATION INFORMATION

<u>Title</u>	Phase Shift Fringe Analysis Method and Apparatus Using the Same
<u>Total # Draw Sheets</u>	5
<u>Suggested Figure for Publication</u>	1
<u>Atty Docket Number</u>	KAW-269-USAP
<u>Type of Application</u>	Utility

(4) REPRESENTATIVE INFORMATION

Ronald R. Snider

Reg. # 24,962

S/N: TBA

1/22/2002

DOCKET NO.: KAW-269-USAP

(5) DOMESTIC PRIORITY INFORMATION

None

(6) FOREIGN PRIORITY INFORMATION

Application Number 2001-23200
Country Japan
Filing Date January 31, 2001

Application Number 2001-399179
Country Japan
Filing Date December 28, 2001

(7) ASSIGNEE INFORMATION

Name Fuji Photo Optical Co., Ltd.
Address 1-324, Uetakecho
Saitama-shi, Saitama 330-8624
JAPAN